



Docket No. 0524-0139.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
)
Nozawa et al.)
)
Serial No.: 10/771,997)
)
Filed: February 4, 2004)
)
For: Manufacturing Method And Apparatus of)
Phase Mask Shift Blank)
)
Examiner: Steven Versteeg)
)
Art Unit: 1753)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450 on

July 7, 2005
(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 7/7/05
Signature Date

AMENDMENT C (AFTER FINAL)

Commissioner of Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Rejection of March 9, 2005, a one month extension of time being submitted herewith, please enter the following amendment in the above-identified application: